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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sheu, *et al.* Docket No.: TSM03-0140
Serial No.: 10/619,828 Art Unit: 2829
Filed: July 15, 2003 Examiner: Dana Farahani
For: Self-Aligned MOSFET having an Oxide Region below the Channel

Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

Date of Deposit: May 16, 2005

I hereby certify that the following documents, which are enclosed, are being deposited with the United States Postal Service "First Class Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450:

Certificate of Mailing via First Class Mail (1 page)
Response to Office Action (4 pages)
Information Disclosure Statement (1 original and 1 copy = 2 pages)
IDS Form PTO/SB/08a and 08b (6 pages) citing 52 references
Copies of (5) references
Return Postcard

Respectfully submitted,

Judy A. Betts
Legal Assistant

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Response to Office Action

Dear Sir:

Applicants respectfully submit the following remarks in response to Examiner's Office Action mailed February 16, 2005. They are believed to be a full and complete response to said Action.